PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Takako HAYAKAWA	06/10/2009
Yoshiyuki HIRONO	06/11/2009
Hideaki MAEDA	06/23/2009
Masaru MURANISHI	06/10/2009
Kouki UEFUNE	06/10/2009

RECEIVING PARTY DATA

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PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	12488501	

CORRESPONDENCE DATA

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NAME OF SUBMITTER:	Amber Grewer

REEL: 025103 FRAME: 0113

PATENT

Total Attachments: 1

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PATENT REEL: 025103 FRAME: 0114

ASSIGNMENT FOR PATENT APPLICATION

Whereas, I/we the undersigned inventor(s) have invented certain improvements as set forth in the patent application entitled:

A DISK DRIVE AND METHOD OF RE-INJECTING LOW DENSITY GAS IN A HERMETICALLY SEALED DISK ENCLOSURE OF A DISK DRIVE

Whereas, Hitachi Global Storage Technologies Netherlands B.V., having a place of business at Locatellikade 1, Parnassustoren, 1076 AZ Amsterdam, The Netherlands (hereinafter referred to as "HITACHI"), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefore;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I/we, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to HITACHI, its successors and assigns; and we hereby agree that HITACHI may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.

Signed on the date(s) indicated beside my (our) signature(s).

1)	Signature: Taka Co haya ka Wa Typed Name: Takako HAYAKAWA	Date: 6/10/2009
2)	Signature: Yoshiyuki HIRONO Yoshiyuki HIRONO	Date: 6/11/2009
3)	Signature: Hideaki Maeda Typed Name: Hideaki MAEDA	Date: 6/23/2009
4)	Signature: Masaru Muranishi Typed Name: Masaru MURANISHI	Date: 6/10/2009
5)	Signature: KOVKi Vetume Typed Name: Kouki UEFUNE	Date: 6/10/2001

Docket No.:HJP920070137US1

RECORDED: 10/06/2010

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